



ELECTRONIC COPY

LG784689215
Report verification at igi.org



March 25, 2026
IGI Report Number **LG784689215**
Description **LABORATORY GROWN DIAMOND**
Shape and Cutting Style **MARQUISE BRILLIANT**
Measurements **10.31 X 5.41 X 3.41 MM**
GRADING RESULTS
Carat Weight **1.10 CARAT**
Color Grade **D**
Clarity Grade **VVS 2**

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GRADING RESULTS

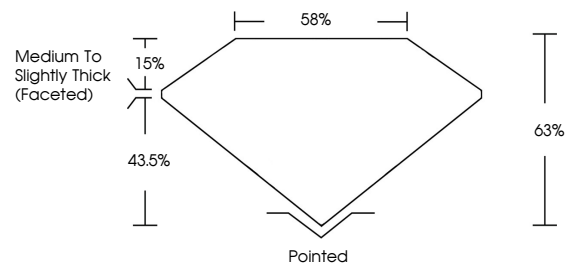
Carat Weight **1.10 CARAT**
Color Grade **D**
Clarity Grade **VVS 2**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**
Symmetry **EXCELLENT**
Fluorescence **NONE**
Inscription(s) **IGI LG784689215**

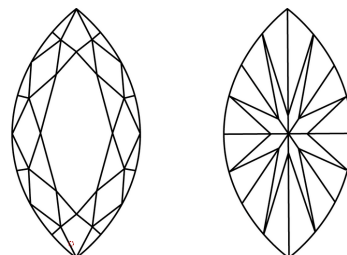
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

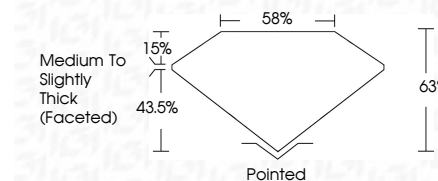
Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

| FL | IF | VVS ¹⁻² | VS ¹⁻² | SI ¹⁻² | I ¹⁻³ |
|----------|---------------------|-----------------------------|------------------------|-------------------|------------------|
| Flawless | Internally Flawless | Very Very Slightly Included | Very Slightly Included | Slightly Included | Included |



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IGI Report No **LG784689215**
MARQUISE BRILLIANT
1.10 CARAT
Carat Weight **D**
Color Grade **VVS 2**
Clarity Grade **63%**
Depth **85%**
Table
Girdle
Medium to Slightly Thick (Faceted)
Culet
Pointed
Polish **EXCELLENT**
Symmetry **EXCELLENT**
Fluorescence **NONE**
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